

03560.002157.1



*Receipt*  
PATENT APPLICATION

3/B  
B/H  
6/10/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MASAFUMI SANO ET AL. ) : Examiner: NYA  
Application No.: 10/046,903 ) : Group Art Unit: 1741  
Filed: January 17, 2002 ) :  
For: METHOD OF PRODUCING ) : JUN 05 2002  
ZINC OXIDE THIN FILM, ) :  
METHOD OF PRODUCING ) :  
PHOTOVOLTAIC DEVICE ) :  
AND METHOD OF ) :  
PRODUCING ) :  
SEMICONDUCTOR DEVICE ) : May 21, 2002

**RECEIVED**

JUN 05 2002

**TC 1700**

Commissioner for Patents  
Washington, D.C. 20231

PRELIMINARY SUPPLEMENTAL AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows.

IN THE SPECIFICATION

At page 1, after the title, please substituted the following paragraph. A marked up version, showing the changes made thereto, is attached.

--CROSS REFERENCE TO RELATED APPLICATION

*b1*